

**Remarks**

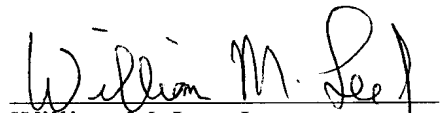
In response to the requirement for restriction, the applicant elects, with traverse, Group I, consisting of claims 1 through 10.

However, reconsideration is requested. In his comments, the examiner asserts that a waveguide laser diode can be made without mirrors. That, however, is erroneous. To make the point abundantly clear, claim 11 has been amended above. Consequently, it is submitted that claims 11 through 13 should remain in the application and be considered with claims 1 through 10.

Further action on the application is awaited.

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Respectfully submitted,

  
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**Version With Markings To Show Changes Made**

11. (Amended) A method of making a high power ridge waveguide laser diode with front and back facets each with a mirror, including
- providing at least one unpumped end section by inserting a patterned isolation layer (11, 13) between the laser diode's active region (2, 3, 4) and a metallization (6) injecting carriers into said active region.